



Docket No. 740819-723

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: )  
Masahiro ISHIDA ) Group Art Unit: 2823  
Serial No.: 10/032,563 ) Examiner: Julio J. MALDONADO  
Filed: January 2, 2002 ) Confirmation No.: 5817  
For: METHOD OF MANUFACTURING ) Date: July 14, 2003  
NITRIDE SEMICONDUCTOR  
SUBSTRATE

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: **Mail Stop Fee Amendments**, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on July 14, 2003.

Signature: \_\_\_\_\_

Name: Linda C. Haynes

**AMENDMENT**

**Mail Stop FEE AMENDMENTS**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed March 13, 2003, the due date for which having been extended one (1) month to July 13, 2003, please consider the remarks and amendments in connection with the above-identified application.

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